

Notice of References Cited

Application/Control No.

09/421,434

Applicant(s)/Patent Under

Reexamination

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Examiner

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Art Unit

3729

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*		Document Number	Date	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY			
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.